



00862.0022167

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2851

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shinichi HARA et al.

Application No.: 09/818,625

Filed: March 28, 2001

For: EXPOSURE APPARATUS, GAS REPLACEMENT ) June 20, 2003  
METHOD, SEMICONDUCTOR DEVICE )  
MANUFACTURING METHOD, SEMICONDUCTOR) :  
MANUFACTURING FACTORY, AND EXPOSURE :  
APPARATUS MAINTENANCE METHOD )

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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

LETTER TRANSMITTING CORRECTED FORMAL DRAWINGS

Sir:

Transmitted herewith are two (2) formal drawing sheets, Figures 3 and 13, to be substituted for the corresponding drawing sheets currently on file in the above-identified application.

Figures 3 and 13 incorporate the changes requested by Applicants in a Request for Approval of Drawing Changes filed on February 28, 2003, which were subsequently approved by the Examiner in the Office Action dated March 21, 2003.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Steven E. Warner", is written over a horizontal line.

Attorney for Applicants

Steven E. Warner

Registration No. 33,326

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FIG. 3

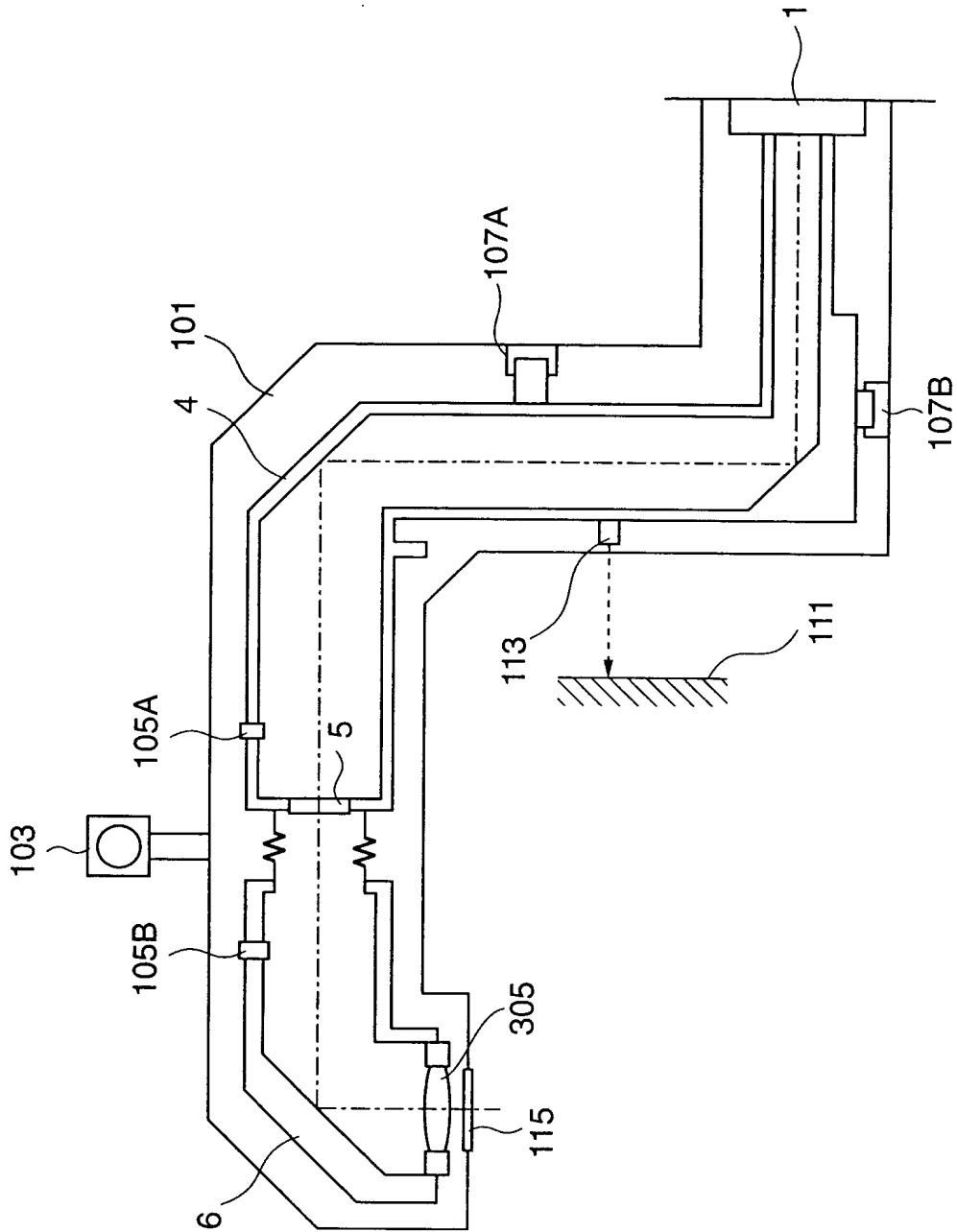




FIG. 13

